

Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title::

METHOD FOR FORMING SILICON FILM WITH
CHANGING GRAIN SIZE BY THERMAL
PROCESS

Attorney Docket Number::

MXIC 1532-1

Request for Early Publication?::

No

Request for Non-Publication?::

No

Suggested Drawing Figure::

3

Total Drawing Sheets::

6

Small Entity?::

No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: CHINA
Status:: Full Capacity
Given Name:: CHIH
Middle Name:: YUAN
Family Name:: HUANG
City of Residence:: HSINCHU
State or Province of Residence:: TAIWAN
Country of Residence:: ROC
Street of mailing address:: NO. 101 SI-TAI ROAD
City of mailing address:: HSINCHU
State or Province of mailing address:: TAIWAN
Country of mailing address:: ROC

Applicant Authority Type:: Inventor
Primary Citizenship Country:: CHINA
Status:: Full Capacity
Given Name:: JONASON
Family Name:: CHEN
City of Residence:: HSINCHU
State or Province of Residence:: TAIWAN
Country of Residence:: ROC
Street of mailing address:: NO. 34 Sec. 2 Road Kun-Fu
City of mailing address:: HSINCHU
State or Province of mailing address:: TAIWAN
Country of mailing address:: ROC

Correspondence Information

Correspondence Customer Number:: 22470

Representative Information

Representative Customer Number::	22470	
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- OR -

Representative Designation::	Registration Number::	Representative Name::

Assignee Information

Assignee name::	MACRONIX INTERNATIONAL CO. LTD
Street of mailing address::	NO. 16 LI-HSIN ROAD
	SCIENCE-BASED INDUSTRIAL PARK
City of mailing address::	HSINCHU
State or Province of mailing address::	TAIWAN
Country of mailing address::	ROC